

# NANOSOURCE IAPP-Marie Curie project



## Participants:

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  - Mantisdeposition Ltd, Thame, Oxfordshire OX9 3BX, UK



## Goal of the project

The goal of the NANOSOURCE project (2008-12) was to develop techniques for the deposition of metal and semiconducting nanoparticle materials. Specific areas of interest for applications include electronic and optoelectronic devices, sensor devices and self-assembly techniques.

## Deposition method

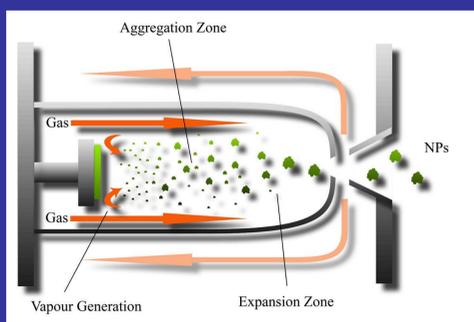
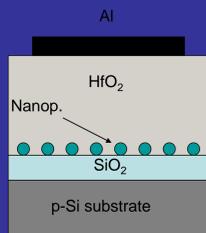


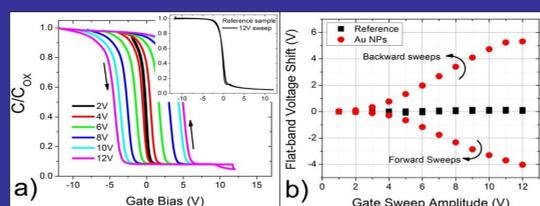
Figure illustrates the generation of nanoparticles, in which a magnetron attracts ionized argon gas, sputtering the platinum target material into the aggregation zone. The pressure (approximately 1 mbar) causes the sputtered material to aggregate to form particles that increase in size until they reach the expansion zone. The nanoparticles then entered a second chamber with lower pressure ( $3 \times 10^{-3}$  mbar) where they were deposited onto the substrate. The argon gas flow rate and distance traveled through the aggregation zone can be adjusted to produce nanoparticles of a controllable size onto the substrate, although to ensure that the dynamics were consistent for each sample only the deposition duration was varied.

## Nanoparticle memory devices (Pt, Au nps)



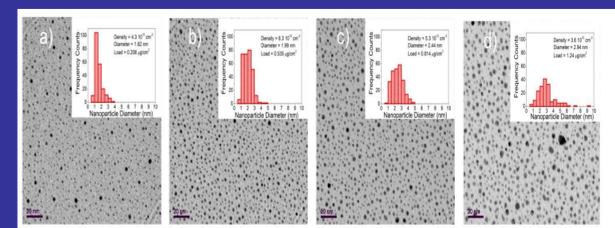
Test devices used to observe charge storage in gold nanoparticles

## Electrical Results



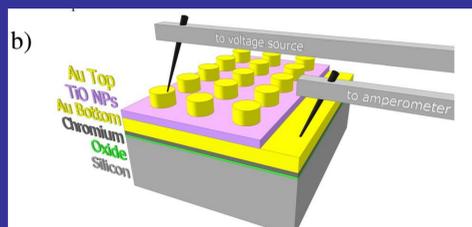
C-V sweeps used to investigate the memory effect

## TEM results

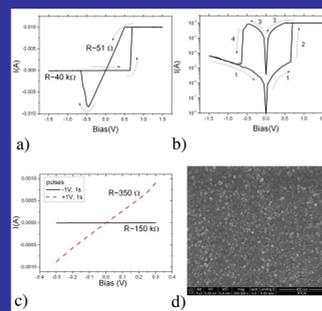


TEM images showing ultra miniature nanoparticles. Their use has a pronounced memory effect!

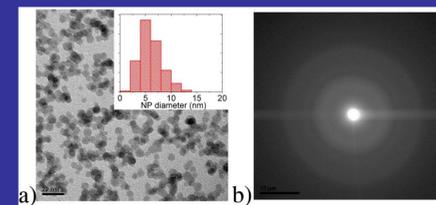
## Memristive Devices (TiO2 nps)



Two terminal Au/TiO2 nps/Au devices realized

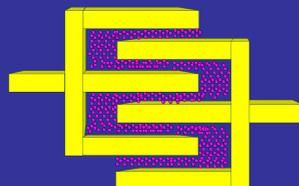
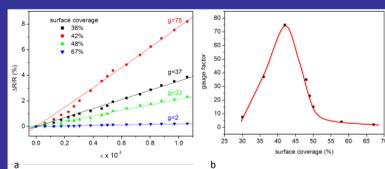


I-V characteristics showing the resistive memory behavior



TEM images showing the amorphous TiO2 nps used in the memristor

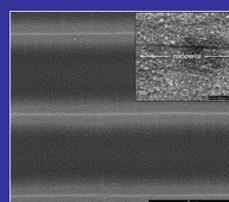
## Nanoparticle Sensors (Strain and chemical sensors)



On the left: Strain gauge measurements of a nanoparticle sensor showing an order of magnitude increase compared with continuous metal films.

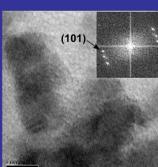
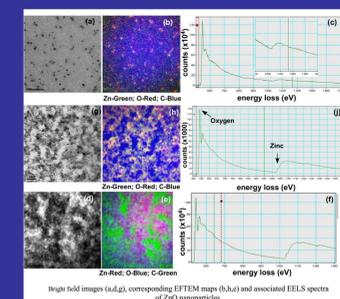
On the right: Device used with nps deposited between IDE

## Self-assembled Nanoparticles



Silver nanoparticles self-assembled into nanowires exhibit increased SERS signal of rhodamine

## Material Studies: ZnO nps



## Publications:

- 'High strain sensitivity controlled by surface density of Pt nanoparticles' Nanotechnology 23 285501 (2012)
- 'Raman enhancement of rhodamine absorbed on Ag nanoparticles self-assembled on nanowire-like arrays', Nanoscale Research Letters 6:629 (2011)
- 'Electrostatic self-assembly of nanoparticles into ordered nanowire arrays' J. Materials Research 26 209 (2011)
- 'Two dimensional nanoparticle self-assembly using plasma activated Ostwald ripening', Nanotechnology 22 235306 (2011)
- 'Optimization of hafnium oxide for use in nanoparticle memories' Microelectronic Engineering, Volume 88, Issue 7, July 2011, Pages 1189-1193
- 'ZnO nanoparticles produced by novel physical deposition process', Appl. Surface Sci., 257, 5366 (2011)
- 'Assembly of charged nanoparticles using self-electrodynamics focusing', Nanotechnology, 20, 36 365605 (2009)

## Acknowledgments:



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